

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE 2812

Applicant:

Xu et al.

Filed: May 10, 2001

Serial No. 09/854,177

For: METHOD AND SYSTEM FOR
DETECTING METAL CONTAMINATION
ON A SEMICONDUCTOR WAFER

Attorney Dkt. No. 5589-00501

I hereby certify that this correspondence is being transmitted
via facsimile to USPTO, TC2800, 703/872-9318 on the date
indicated below:

April 26, 2002
Date

Pamela Gerik
Pamela Gerik

POWER OF ATTORNEY BY ASSIGNEE

Under the provisions of 37 C.F.R. § 3.71, the undersigned assignee of record of the entire interest in the above-identified patent/patent application by virtue of an assignment recorded (check as applicable):

☐ Concurrently herewith
☐ Date Recorded
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elects to conduct the prosecution of the application/maintenance of the patent to the exclusion of the inventor(s). The undersigned hereby declares that he has reviewed the above-referenced assignment and hereby declares that, to the best of his knowledge, title is in the Assignee, and further declares that all statements made herein of his own knowledge are true and that all statements made on information and belief are believed to be true. The assignee hereby revokes any previous powers of attorney and appoints the following to prosecute this application/maintain this patent and transact all business in the Patent and Trademark Office connected therewith:

Kevin McAndrews, Reg. No. 34,496 and Marius Domokos, Reg. No. 48,153 of KLA-Tencor, Inc.

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ASSIGNEE
KLA-TENCOR, INC.

Date:

4/22/02

BY:

Stuart Nichols
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